



SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
55071-268SERIAL NO.
10/626,864APPLICANT
Xuelong SHI, et al.FILING DATE
July 25, 2003

GROUP 2825

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code(s) (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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						Yes	No
NL		WO 99/14638	03/25/1999	NUMERICAL TECHNOLOGIES, INC.		x	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
NL		HEWAK, Daniel, et al. "Fabrication of tapers and lenslike waveguides by a microcontrolled dip coating procedure." Applied Optics, Volume 27, Number 21, November 1, 1988, pp. 4562-4564
NL		TORRES, J.A., et al. "Contrast-based assist feature optimization photolithography." Optical Microlithography XV, Santa Clara CA, March 5-8 2002, Volume 4691, pp. 179-187, XP 000118758, ISSN: 0277-788X

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